#6A PRO JUDY. CE M. BRUNSA 4/14/02 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Dr. Michael Abraham, et al.

Examiner:

Serial No:

Group Art Unit:

Filed:

August 27, 2001

Date:

August 27, 2001

For: VACUUM MEASUREMENT DEVICE

Assistant Commissioner for Patents

Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Please amend the application as indicated below before calculation of the application fees as follows:

IN THE SPECIFICATION:

Page 1:

Please replace the first paragraph as follows:

FIELD OF THE INVENTION

The invention relates to a device to carry out measurements in a vacuum chamber, in particular to measure thin layers, with a case, exhibiting at least one measurement window, to receive a measurement system.

Ö E. I